

Application No.: 09/943,955
Docket No.: 5918/FPS/MMCS/APC/DV

PATENT/OFFICIAL

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

SHANMUGASUNDRAM et al.

Serial No. 09/943,955

Filed: August 31, 2001

For: FEEDBACK CONTROL OF CHEMICAL MECHANICAL POLISHING DEVICE
PROVIDING MANIPULATION OF REMOVAL RATE PROFILES



Group Art Unit: 1765

Examiner: L.T. Umez Eronini

*Fee
Record*

CERTIFICATE OF FIRST CLASS MAILING UNDER 37 CFR § 1.18

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on the date indicated below.

Date:

9/14/04

Janet McKean
Janet McKean

Commissioner for Patents
U.S. Patent and Trademark Office
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AND RESPONSE

Sir:

This Amendment and Response is responsive to an Office Communication dated May 5, 2004, and is accompanied by a petition for two month extension of time to extend the period of response up to and including October 5, 2004. Please amend the above-identified application as follows.

Amendments to the Specification begin on *page 2*.

Amendments to the Claims are reflected in the listing of claims, which begins on *page 5* of this paper.

Remarks/Arguments begin on *page 14* of this paper.

Docket No.: Please change the Attorney Docket No. to: 5918/FPS/MMCS/APC/DV

09/20/2004 YPOLITE1 00000024 080219 09943955
01 FC:1252 420.00 DA

1

10/06/2004 WHITCHEL 00000003 080219 09943955
01 FC:1201 86.00 DA
02 FC:1202 72.00 DA